

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Group Art Unit: 2818
Toru TAKAYAMA et al.)	Examiner: T. Le
Serial No. 10/664,866)	CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on July 15, 2005.
Filed: September 22, 2003)	
For: METHOD FOR MANUFACTURING)	
SEMICONDUCTOR DEVICE AND)	
HEAT TREATMENT METHOD)	

AMENDMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated March 15, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.